Application of Chen Application No. 09/667,966

<u>AMENDMENTS</u>

Please amend the above-identified application, as follows:

In the Claims:

Please delete claims 2, 18, and 19.

Please replace claims 1, 3, 7,18, 23, 41, 44-48 and add new claims 49 and 50 as set forth below.



1. (Amended) A total-reflection x-ray fluorescence apparatus comprising:
an x-ray source for providing x-rays;

a doubly-curved x-ray optic for diffracting and focusing the x-rays provided by the x-ray source;

a surface onto which at least some of the diffracted and focused x-rays are directed; and

an x-ray detector for detecting resultant x-ray fluorescence emitted by any foreign matter present on the surface.



48. (Amended) An apparatus as recited in claim 1 wherein the doubly-curved x-ray optic is a crystal or multi-layer x-ray optic.



7. (Amended) An apparatus as recited in claim 6 wherein the one or more apertures are positioned before the x-ray optic.



33 48. (Amended) A method for detecting presence of foreign matter on a surface by total x-ray diffraction using a doubly-curved x-ray optic, comprising: providing a source of x-rays;

diffracting and focusing at least some of the x-rays using a doubly-curved x-ray optic and impinging the diffracted and focused x-rays upon the surface; and

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detecting flourescent x-rays responsive to the impingement from any foreign matter present on the surface.

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23. (Amended) A method as recited in claim 22, wherein the passing through at least one aperture is practiced before the x-ray optic.



A1. (Amended) An apparatus as recited in claim 1 wherein the x-ray source and the point of impingement upon the surface define an optic circle of radius R, and wherein the doubly-curved x-ray optic comprises a surface and a plurality of atomic planes of radius R_P which intersect the surface at an angle α ; and wherein the radius of the atomic planes R_P of the doubly-curved x-ray optic is defined by the equation $R_P = 2R \cos \alpha$.

27 44. (Amended) An apparatus as recited in claim 41, wherein the doubly-curved x-ray optic is curved to a toroidal, ellipsoidal, spherical, parabolic, or hyperbolic shape.

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- 2% 45. (Amended) An apparatus as recited in claim 44, wherein the doubly-curved x-ray optic exhibits asymmetric Bragg diffraction.
- 2946.(Amended) An apparatus as recited in claim 41, wherein the doubly-curved x-ray optic also focuses the x-rays on to the surface.
- 3047. (Amended) An apparatus as in claim 46, wherein the doubly-curved x-ray optic focuses x-rays to a footprint on the surface and wherein the footprint comprises a largest dimension less than 1 mm.
- 31 48. (Amended) An apparatus as in claim 37, wherein the doubly-curved x-ray optic focuses x-rays to a footprint on the surface wherein the footprint comprises a largest dimension less than 500 microns.

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Please introduce the following new claims:

8 49. (New) An apparatus as recited in claim 8, wherein the one or more apertures are positioned after the x-ray optic.

(New) A method as recited in claim 22, wherein the passing through at least one aperture is practiced after the x-ray optic.